

Search Notes 				Application/Control No.	Applicant(s)/Patent under Reexamination	
				10/757,782	WUNSH ET AL.	
				Examiner	Art Unit	
				José V. Chen	3637	
SEARCHED				SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
Class	Subclass	Date	Examiner		DATE	EXMR
108	25 26 27	9/14/15	JLC	base GE for soft-Art	9/20/15	04
	12			UPDAD	9/10/15	
	14			UPDATION	2/20/17	04
	13					
	40					
	161					
206	769					
	770					
	314					
UPDATION 5/1/2016 JLC UPDATION 9/14/15 JLC UPDATION 2/20/17 JLC						
INTERFERENCE SEARCHED						
Class	Subclass	Date	Examiner			